

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideharu ITATANI et al.

Application No.: 10/521,248

Filed: April 11, 2005

Docket No.: 122430

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND SUBSTRATE  
PROCESSING APPARATUS

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Specification;**

**Remarks.**